

Supporting Information

Azido- and Amido-substituted Gallium Hydrides Supported by *N*-Heterocyclic Carbenes

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Table S1. Crystallographic data for compound **1***A. Crystal Data*

formula	C _{24.50} H ₃₀ GaN ₅
formula weight	464.25
crystal dimensions (mm)	0.15×0.11×0.03
crystal system	monoclinic
space group	P2 ₁ /c (No. 14)
unit cell parameters ^a	
<i>a</i> (Å)	18.7477 (5)
<i>b</i> (Å)	8.4344 (2)
<i>c</i> (Å)	15.3559 (4)
β (deg)	95.0657 (17)
<i>V</i> (Å ³)	2418.68 (11)
<i>Z</i>	4
ρ_{calcd} (g cm ⁻³)	1.275
μ (mm ⁻¹)	1.700

B. Data Collection and Refinement Conditions

diffractometer	Bruker D8/APEX II CCD ^b
radiation (λ [Å])	Cu K α (1.54178) (microfocus source)
temperature (°C)	-100
scan type	ω and ϕ scans (1.0°) (5 s exposures)
data collection 2 θ limit (deg)	139.98
total data collected	15845 (-18 ≤ <i>h</i> ≤ 21, -10 ≤ <i>k</i> ≤ 10, -18 ≤ <i>l</i> ≤ 18)
independent reflections	4451 ($R_{\text{int}} = 0.0706$)
number of observed reflections (<i>NO</i>)	3400 [$F_o^2 \geq 2\sigma(F_o^2)$]
structure solution method	intrinsic phasing (<i>SHELXT-2014^c</i>)
refinement method	full-matrix least-squares on F^2 (<i>SHELXL-2014^d</i>)
absorption correction method	Gaussian integration (face-indexed)
range of transmission factors	0.9950–0.7737
data/restraints/parameters	4451 / 0 / 308
goodness-of-fit (<i>S</i>) ^e [all data]	1.039
final <i>R</i> indices ^f	
<i>R</i> ₁ [$F_o^2 \geq 2\sigma(F_o^2)$]	0.0668
<i>wR</i> ₂ [all data]	0.1905
largest difference peak and hole	1.249 and -0.629 e Å ⁻³

^aObtained from least-squares refinement of 5294 reflections with 9.48° < 2 θ < 136.10°.

^bPrograms for diffractometer operation, data collection, data reduction and absorption correction were those supplied by Bruker.

^cSheldrick, G. M. *Acta Crystallogr.* **2015**, *A71*, 3–8. (*SHELXT-2014*)

^dSheldrick, G. M. *Acta Crystallogr.* **2015**, *C71*, 3–8. (*SHELXL-2014*)

^e $S = [\sum w(F_o^2 - F_c^2)^2 / (n - p)]^{1/2}$ (n = number of data; p = number of parameters varied; $w = [\sigma^2(F_o^2) + (0.0962P)^2 + 2.9865P]^{-1}$ where $P = [\text{Max}(F_o^2, 0) + 2F_c^2]/3$).

^f $R_1 = \Sigma ||F_o| - |F_c|| / \Sigma |F_o|$; $wR_2 = [\sum w(F_o^2 - F_c^2)^2 / \sum w(F_o^4)]^{1/2}$.

Table S2. Crystallographic data for compound **2**

<i>A. Crystal Data</i>	
formula	C ₂₃ H ₂₅ F ₆ GaN ₂ O ₆ S ₂
formula weight	673.29
crystal dimensions (mm)	0.25×0.16×0.10
crystal system	monoclinic
space group	P2 ₁ /c (No. 14)
unit cell parameters ^a	
<i>a</i> (Å)	12.2187 (10)
<i>b</i> (Å)	15.2841 (13)
<i>c</i> (Å)	15.7675 (13)
β (deg)	102.522 (4)
<i>V</i> (Å ³)	2874.6 (4)
<i>Z</i>	4
ρ_{calcd} (g cm ⁻³)	1.556
μ (mm ⁻¹)	3.391
<i>B. Data Collection and Refinement Conditions</i>	
diffractometer	Bruker D8/APEX II CCD ^b
radiation (λ [Å])	Cu K α (1.54178) (microfocus source)
temperature (°C)	-100
scan type	ω and ϕ scans (1.0°) (5 s exposures)
data collection 2 θ limit (deg)	145.34
total data collected	19732 (-15 ≤ <i>h</i> ≤ 15, -18 ≤ <i>k</i> ≤ 18, -19 ≤ <i>l</i> ≤ 19)
independent reflections	5488 ($R_{\text{int}} = 0.0240$)
number of observed reflections (<i>NO</i>)	5048 [$F_{\text{o}}^2 \geq 2\sigma(F_{\text{o}}^2)$]
structure solution method	intrinsic phasing (<i>SHELXT-2014^c</i>)
refinement method	full-matrix least-squares on F^2 (<i>SHELXL-2014^d</i>)
absorption correction method	Gaussian integration (face-indexed)
range of transmission factors	0.8317–0.5732
data/restraints/parameters	5488 / 0 / 371
goodness-of-fit (<i>S</i>) ^e [all data]	1.079
final <i>R</i> indices ^f	
<i>R</i> ₁ [$F_{\text{o}}^2 \geq 2\sigma(F_{\text{o}}^2)$]	0.0330
<i>wR</i> ₂ [all data]	0.0988
largest difference peak and hole	0.355 and -0.468 e Å ⁻³

^aObtained from least-squares refinement of 9649 reflections with $7.42^\circ < 2\theta < 145.14^\circ$.

^bPrograms for diffractometer operation, data collection, data reduction and absorption correction were those supplied by Bruker.

^cSheldrick, G. M. *Acta Crystallogr.* **2015**, *A71*, 3–8. (*SHELXT-2014*)

^dSheldrick, G. M. *Acta Crystallogr.* **2015**, *C71*, 3–8. (*SHELXL-2014*)

^e $S = [\sum w(F_o^2 - F_c^2)^2 / (n - p)]^{1/2}$ (n = number of data; p = number of parameters varied; $w = [\sigma^2(F_o^2) + (0.0518P)^2 + 1.8037P]^{-1}$ where $P = [\text{Max}(F_o^2, 0) + 2F_c^2]/3$).

^f $R_1 = \Sigma ||F_o| - |F_c|| / \Sigma |F_o|$; $wR_2 = [\sum w(F_o^2 - F_c^2)^2 / \sum w(F_o^4)]^{1/2}$.

Table S3. Crystallographic data for compound 3*A. Crystal Data*

formula	C ₂₇ H _{43.85} Cl _{0.15} GaN ₃ Si ₂
formula weight	541.72
crystal dimensions (mm)	0.37×0.24×0.12
crystal system	triclinic
space group	<i>P</i>  (No. 2)
unit cell parameters ^a	
<i>a</i> (Å)	9.3467 (2)
<i>b</i> (Å)	9.9910 (2)
<i>c</i> (Å)	18.9915 (4)
α (deg)	81.5099 (8)
β (deg)	79.0123 (7)
γ (deg)	62.4631 (8)
<i>V</i> (Å ³)	1540.13 (6)
<i>Z</i>	2
ρ_{calcd} (g cm ⁻³)	1.168
μ (mm ⁻¹)	2.213

B. Data Collection and Refinement Conditions

diffractometer	Bruker D8/APEX II CCD ^b
radiation (λ [Å])	Cu K α (1.54178) (microfocus source)
temperature (°C)	-100
scan type	ω and ϕ scans (1.0°) (5 s exposures)
data collection 2 θ limit (deg)	147.80
total data collected	11040 (-11 ≤ <i>h</i> ≤ 11, -12 ≤ <i>k</i> ≤ 12, -23 ≤ <i>l</i> ≤ 23)
independent reflections	5997 ($R_{\text{int}} = 0.0124$)
number of observed reflections (<i>NO</i>)	5883 [$F_{\text{o}}^2 \geq 2\sigma(F_{\text{o}}^2)$]
structure solution method	intrinsic phasing (<i>SHELXT-2014^c</i>)
refinement method	full-matrix least-squares on F^2 (<i>SHELXL-2014^d</i>)
absorption correction method	Gaussian integration (face-indexed)
range of transmission factors	0.5707–0.3806
data/restraints/parameters	5997 / 1 ^e / 321
goodness-of-fit (<i>S</i>) ^f [all data]	1.061
final <i>R</i> indices ^g	
<i>R</i> ₁ [$F_{\text{o}}^2 \geq 2\sigma(F_{\text{o}}^2)$]	0.0296
<i>wR</i> ₂ [all data]	0.0828
largest difference peak and hole	0.305 and -0.255 e Å ⁻³

^aObtained from least-squares refinement of 9191 reflections with 11.16° < 2 θ < 147.66°.

^bPrograms for diffractometer operation, data collection, data reduction and absorption correction were those supplied by Bruker.

^cSheldrick, G. M. *Acta Crystallogr.* **2015**, *A71*, 3–8. (*SHELXT-2014*)

^dSheldrick, G. M. *Acta Crystallogr.* **2015**, *C71*, 3–8. (*SHELXL-2014*)

^eThe Ga–H distances were restrained to be approximately the same by use of the *SHELXL SAME* instruction.

$fS = [\sum w(F_o^2 - F_c^2)^2 / (n - p)]^{1/2}$ (n = number of data; p = number of parameters varied; $w = [\sigma^2(F_o^2) + (0.0417P)^2 + 0.7628P]^{-1}$ where $P = [\text{Max}(F_o^2, 0) + 2F_c^2]/3$).

$gR_1 = \sum ||F_o| - |F_c|| / \sum |F_o|$; $wR_2 = [\sum w(F_o^2 - F_c^2)^2 / \sum w(F_o^4)]^{1/2}$.

Table S4. Crystallographic data for compound 4*A. Crystal Data*

formula	C ₄₀ H _{71.50} Cl ₂ GaN ₃ O _{1.75} Si ₂
formula weight	819.30
crystal dimensions (mm)	0.30×0.25×0.18
crystal system	monoclinic
space group	P2 ₁ /c (No. 14)
unit cell parameters ^a	
<i>a</i> (Å)	12.2392 (2)
<i>b</i> (Å)	36.3301 (7)
<i>c</i> (Å)	11.9340 (2)
β (deg)	117.5323 (6)
<i>V</i> (Å ³)	4705.51 (14)
<i>Z</i>	4
ρ_{calcd} (g cm ⁻³)	1.156
μ (mm ⁻¹)	2.576

B. Data Collection and Refinement Conditions

diffractometer	Bruker D8/APEX II CCD ^b
radiation (λ [Å])	Cu K α (1.54178) (microfocus source)
temperature (°C)	-100
scan type	ω and ϕ scans (1.0°) (5 s exposures)
data collection 2 θ limit (deg)	148.22
total data collected	33450 (-15 ≤ <i>h</i> ≤ 15, -45 ≤ <i>k</i> ≤ 45, -14 ≤ <i>l</i> ≤ 14)
independent reflections	9547 ($R_{\text{int}} = 0.0171$)
number of observed reflections (<i>NO</i>)	9244 [$F_{\text{o}}^2 \geq 2\sigma(F_{\text{o}}^2)$]
structure solution method	intrinsic phasing (<i>SHELXT-2014^c</i>)
refinement method	full-matrix least-squares on F^2 (<i>SHELXL-2014^{d,e}</i>)
absorption correction method	Gaussian integration (face-indexed)
range of transmission factors	0.7298–0.5798
data/restraints/parameters	9547 / 0 / 421
goodness-of-fit ($S\sqrt{F}$ [all data])	1.112
final <i>R</i> indices ^g	
R_1 [$F_{\text{o}}^2 \geq 2\sigma(F_{\text{o}}^2)$]	0.0324
wR_2 [all data]	0.0807
largest difference peak and hole	0.312 and -0.229 e Å ⁻³

^aObtained from least-squares refinement of 9234 reflections with 9.50° < 2 θ < 147.56°.

^bPrograms for diffractometer operation, data collection, data reduction and absorption correction were those supplied by Bruker.

^cSheldrick, G. M. *Acta Crystallogr.* **2015**, *A71*, 3–8. (*SHELXT-2014*)

^dSheldrick, G. M. *Acta Crystallogr.* **2015**, *C71*, 3–8. (*SHELXL-2014*)

^eAttempts to refine peaks of residual electron density as disordered or partial-occupancy solvent diethylether oxygen or carbon atoms were unsuccessful. The data were corrected for disordered electron density through use of the SQUEEZE procedure as implemented in *PLATON* (Spek, A. L. *Acta Crystallogr.* **2015**, *C71*, 9–18. *PLATON* - a multipurpose crystallographic tool. Utrecht University, Utrecht, The Netherlands). A total solvent-accessible void volume of 682 Å³ with a total electron count of 132 (consistent with 3 molecules of solvent diethylether, or 0.75 molecules per formula unit of the Ga complex) was found in the unit cell.

^f $S = [\sum w(F_o^2 - F_c^2)^2 / (n - p)]^{1/2}$ (n = number of data; p = number of parameters varied; $w = [\sigma^2(F_o^2) + (0.0268P)^2 + 3.1744P]^{-1}$ where $P = [\text{Max}(F_o^2, 0) + 2F_c^2]/3$).

^g $R_1 = \Sigma ||F_o| - |F_c|| / \Sigma |F_o|$; $wR_2 = [\sum w(F_o^2 - F_c^2)^2 / \sum w(F_o^4)]^{1/2}$.

Table S5. Crystallographic data for compound **5***A. Crystal Data*

formula	C ₃₄ H ₅₄ ClF ₃ GaN ₃ O ₃ SSi ₂
formula weight	803.21
crystal dimensions (mm)	0.24×0.21×0.15
crystal system	monoclinic
space group	P ₂ ₁ /n (an alternate setting of P ₂ ₁ /c [No. 14])
unit cell parameters ^a	
<i>a</i> (Å)	11.1905 (2)
<i>b</i> (Å)	22.5860 (4)
<i>c</i> (Å)	16.2428 (3)
β (deg)	91.6950 (12)
<i>V</i> (Å ³)	4103.55 (13)
<i>Z</i>	4
ρ_{calcd} (g cm ⁻³)	1.300
μ (mm ⁻¹)	2.959

B. Data Collection and Refinement Conditions

diffractometer	Bruker D8/APEX II CCD ^b
radiation (λ [Å])	Cu K α (1.54178) (microfocus source)
temperature (°C)	-100
scan type	ω and ϕ scans (1.0°) (5 s exposures)
data collection 2 θ limit (deg)	148.15
total data collected	26507 (-13 ≤ <i>h</i> ≤ 13, -28 ≤ <i>k</i> ≤ 28, -18 ≤ <i>l</i> ≤ 19)
independent reflections	8220 ($R_{\text{int}} = 0.0581$)
number of observed reflections (<i>NO</i>)	6507 [$F_{\text{o}}^2 \geq 2\sigma(F_{\text{o}}^2)$]
structure solution method	direct methods/dual space (<i>SHELXD</i> ^c)
refinement method	full-matrix least-squares on F^2 (<i>SHELXL-2014</i> ^d)
absorption correction method	Gaussian integration (face-indexed)
range of transmission factors	0.7568–0.5956
data/restraints/parameters	8220 / 23 ^e / 475
goodness-of-fit ($S\sqrt{F}$ [all data])	1.097
final <i>R</i> indices ^g	
R_1 [$F_{\text{o}}^2 \geq 2\sigma(F_{\text{o}}^2)$]	0.0552
wR_2 [all data]	0.1572
largest difference peak and hole	0.597 and -0.549 e Å ⁻³

^aObtained from least-squares refinement of 9974 reflections with 7.82° < 2 θ < 147.72°.

^bPrograms for diffractometer operation, data collection, data reduction and absorption correction were those supplied by Bruker.

(continued)

^cSchneider, T. R.; Sheldrick, G. M. *Acta Crystallogr.* **2002**, D58, 1772–1779.

^dSheldrick, G. M. *Acta Crystallogr.* **2015**, C71, 3–8.

^eCorresponding distances within the two components of the disordered $\text{GaCl}\{\text{N}(\text{SiMe}_3)_2\}$ moiety were constrained to be equal (within 0.03 Å) during refinement: $d(\text{GaA}-\text{ClA}) = d(\text{GaB}-\text{ClB})$; $d(\text{GaA}-\text{N3A}) = d(\text{GaB}-\text{N3B})$; $d(\text{Si1A}-\text{N3A}) = d(\text{Si1B}-\text{N3B})$; $d(\text{Si2A}-\text{N3A}) = d(\text{Si2B}-\text{N3B})$; $d(\text{Si1A}-\text{C5A}) = d(\text{Si1B}-\text{C5B})$; $d(\text{Si1A}-\text{C6A}) = d(\text{Si1B}-\text{C6B})$; $d(\text{Si1A}-\text{C7A}) = d(\text{Si1B}-\text{C7B})$; $d(\text{Si2A}-\text{C8A}) = d(\text{Si2B}-\text{C8B})$; $d(\text{Si2A}-\text{C9A}) = d(\text{Si2B}-\text{C9B})$; $d(\text{Si2A}-\text{C10A}) = d(\text{Si2B}-\text{C10B})$; $d(\text{Si1A} \cdots \text{Si2A}) = d(\text{Si1B} \cdots \text{Si2B})$; $d(\text{N3A} \cdots \text{C5A}) = d(\text{N3B} \cdots \text{C5B})$; $d(\text{N3A} \cdots \text{C6A}) = d(\text{N3B} \cdots \text{C6B})$; $d(\text{N3A} \cdots \text{C7A}) = d(\text{N3B} \cdots \text{C7B})$; $d(\text{N3A} \cdots \text{C8A}) = d(\text{N3B} \cdots \text{C8B})$; $d(\text{N3A} \cdots \text{C9A}) = d(\text{N3B} \cdots \text{C9B})$; $d(\text{N3A} \cdots \text{C10A}) = d(\text{N3B} \cdots \text{C10B})$; $d(\text{C5A} \cdots \text{C6A}) = d(\text{C5B} \cdots \text{C6B})$; $d(\text{C5A} \cdots \text{C7A}) = d(\text{C5B} \cdots \text{C7B})$; $d(\text{C6A} \cdots \text{C7A}) = d(\text{C6B} \cdots \text{C7B})$; $d(\text{C8A} \cdots \text{C9A}) = d(\text{C8B} \cdots \text{C9B})$; $d(\text{C8A} \cdots \text{C10A}) = d(\text{C8B} \cdots \text{C10B})$; $d(\text{C9A} \cdots \text{C10A}) = d(\text{C9B} \cdots \text{C10B})$.

^f $S = [\sum w(F_o^2 - F_c^2)^2 / (n - p)]^{1/2}$ (n = number of data; p = number of parameters varied; $w = [\sigma^2(F_o^2) + (0.0610P)^2 + 6.2812P]^{-1}$ where $P = [\text{Max}(F_o^2, 0) + 2F_c^2]/3$).

^g $R_1 = \Sigma |F_o| - |F_c| / \Sigma |F_o|$; $wR_2 = [\sum w(F_o^2 - F_c^2)^2 / \sum w(F_o^4)]^{1/2}$.

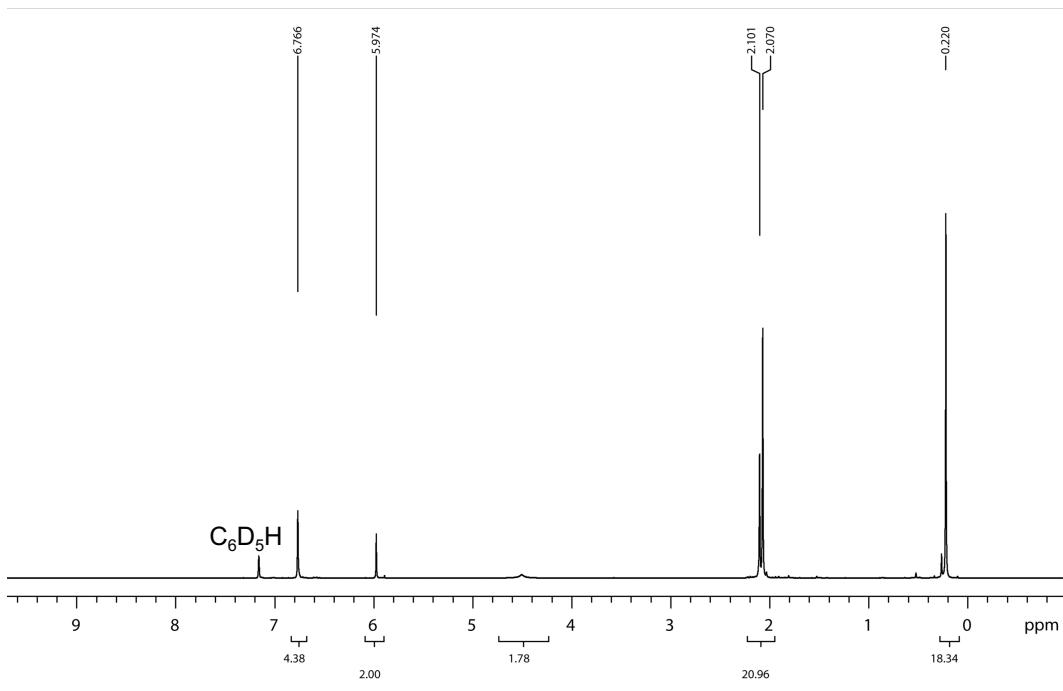


Figure S1: ^1H NMR spectrum of IMes•GaH₂N(SiMe₃)₂ in C₆D₆ (**3**).

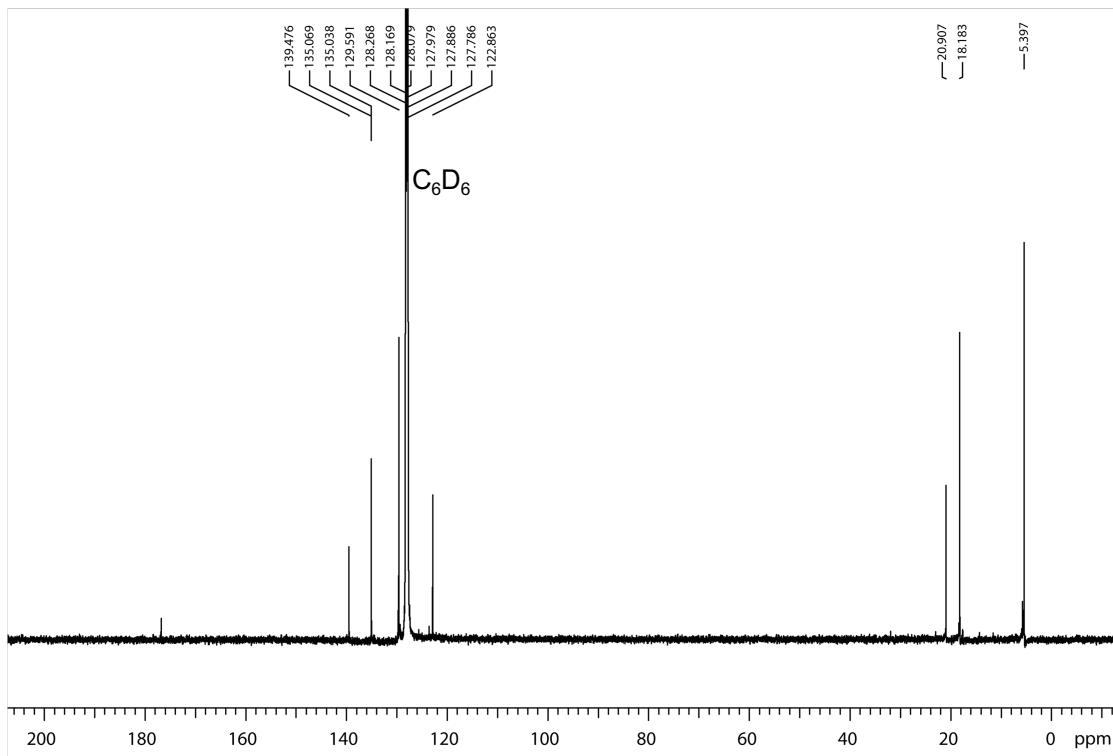


Figure S2: $^{13}\text{C}\{^1\text{H}\}$ NMR spectrum of IMes•GaH₂N(SiMe₃)₂ in C₆D₆ (**3**).